CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 8-18-25



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Docket: 0756-1603

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Patent Application of | |) | AUG 3 0 1999 | |
|-----------------------------|------------------------|------------------|-------------------------|--|
| Shunpei YAMAZAKI et al. | |) | TECHNOLOGY CENTER 2800 | |
| Serial No. 08/841,644 | |) Art Unit: 1104 | | |
| Filed: April 30, 1997 | |) Examir |) Examiner: L. Radomsky | |
| For: | SEMICONDUCTOR DEVICE |) | | |
| | AND METHOD FOR FORMING |) | . • | |
| | THE SAME |) Date: A | August 18, 1999 | |

INFORMATION DISCLOSURE STATEMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R. 1.98(a).

I hereby certify that each item of information contained in this Information

Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement.

Respectfully submitted,

Eric J. Robinson

Registration No. 38,285

Sixbey, Friedman, Leedom & Ferguson, P.C. 8180 Greensboro Drive, Suite 800 McLean, Virginia 22102 (703) 790-9110